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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: TIEN-JEN CHIANG, ET AL. )  
Serial No.: 10/707,047 ) Group Art Unit: 1753  
Filed: November 18, 2003 )  
For: METHOD FOR SELECTIVE ELECTRO- ) Examiner: Van, L.  
PLATING OF SEMICONDUCTOR )  
DEVICE I/O PADS USING A ) Confirmation No.: 1046  
TITANIUM-TUNGSTEN SEED LAYER )

AMENDMENT AFTER FINAL

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Entered per  
RCE filed  
4/10/06 MA

In response to the Final Office Action mailed February 27, 2006, please amend  
the Application as follows: